

# **Structural Optimization of Novel One-Dimensional Composite Based on In-situ Grown 1D CNTs with Amorphous Structure and 2D MoS<sub>2</sub> Nanosheets for Improved Li Storage**

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## **Supporting Information**

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## Captions

**Table S1** Specific surface area of MoS<sub>2</sub>@C-L and MoS<sub>2</sub>@C-H.

**Table S2** EIS Fitting resistance of MoS<sub>2</sub>@C, MoS<sub>2</sub>@C-L and MoS<sub>2</sub>@C-H.

**Fig.S1** SEM images of (a,e) MoS<sub>2</sub>@C-L,(b,e) MoS<sub>2</sub>@C,(c,e) MoS<sub>2</sub>@C-H.

**Fig.S2** EDS mapping of MoS<sub>2</sub>@C (b) C, (c) Mo, (c) S.

**Fig.S3** SEM images of (a) MoS<sub>2</sub>@C-L,(b) MoS<sub>2</sub>@C-L2,(c) MoS<sub>2</sub>@C-L4, (d)MoS<sub>2</sub>@C-L8, (e) MoS<sub>2</sub>@C-L12, (f) MoS<sub>2</sub>@C-L.

**Fig.S4** SEM images of (a) MoS<sub>2</sub>@C-H1, (b) MoS<sub>2</sub>@C-H2, (c) MoS<sub>2</sub>@C-H4, (d) MoS<sub>2</sub>@C-H8, (e)MoS<sub>2</sub>@C-H12, (f) MoS<sub>2</sub>@C-H.

**Fig.S5** XRD patterns of (a) MoS<sub>2</sub>@C-L,(b) MoS<sub>2</sub>@C-H.

**Fig.S6** Raman spectra of MoS<sub>2</sub>@C.

**Fig.S7** TGA result of MoS<sub>2</sub>@C.

**Fig.S8** Rate capability of MoS<sub>2</sub>@C cycled at various rates from 0.1 to 5.0 Ag<sup>-1</sup>.

**Fig.S9** MoS<sub>2</sub>@C-L8, MoS<sub>2</sub>@C-L12 and MoS<sub>2</sub>@C-L at a current density of (a) 0.2 Ag<sup>-1</sup>, (b) 1Ag<sup>-1</sup>.

**Fig.S10** MoS<sub>2</sub>@C-H8, MoS<sub>2</sub>@C-H12 and MoS<sub>2</sub>@C-H at a current density of (a) 0.2 Ag<sup>-1</sup>, (b) 1Ag<sup>-1</sup>.

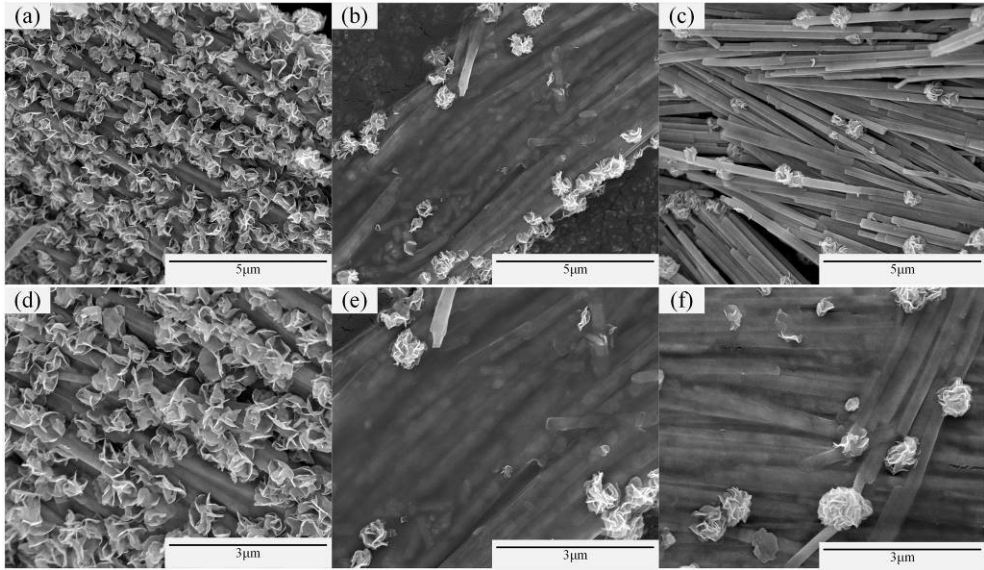
**Fig.S11** EIS of (a) MoS<sub>2</sub>@C-L8, MoS<sub>2</sub>@C-L12 and MoS<sub>2</sub>@C-L,(b) MoS<sub>2</sub>@C-H8, MoS<sub>2</sub>@C-H12 and MoS<sub>2</sub>@C-H.

**Table S1**

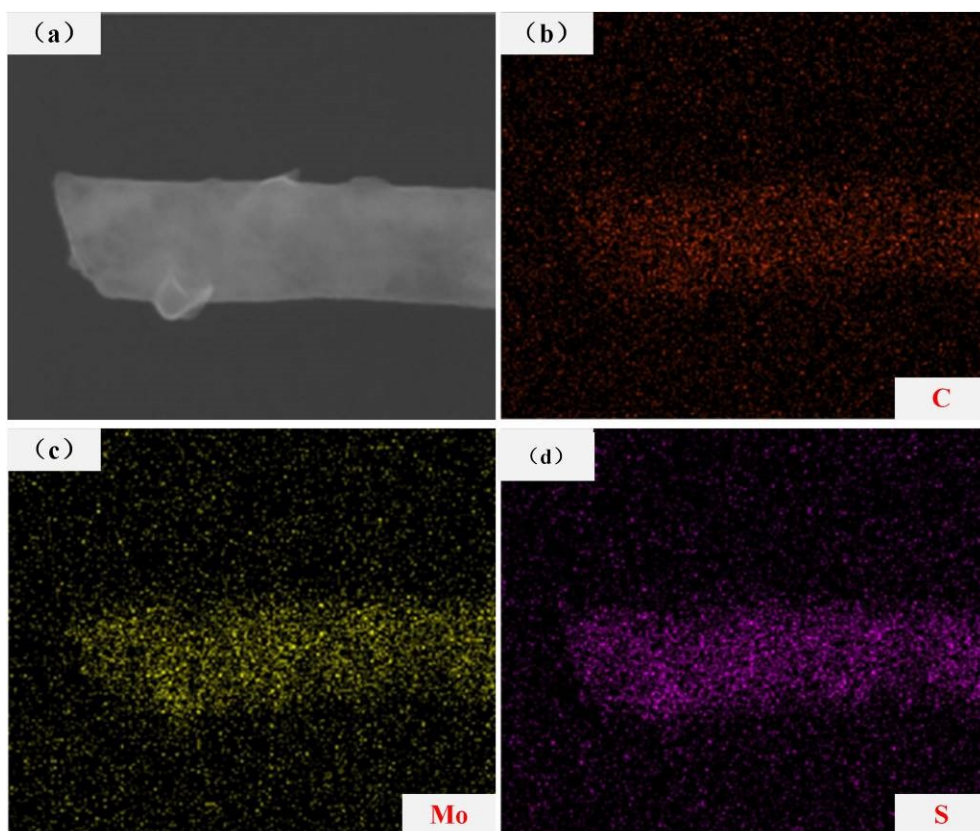
	<b>MoS<sub>2</sub>@C-L</b>	<b>MoS<sub>2</sub>@C-H</b>
BET Surface Area(m <sup>2</sup> g <sup>-1</sup> )	64.3534	35.1899
Langmuir Surface Area(m <sup>2</sup> g <sup>-1</sup> )	65.7454	27.2338
Adsorption average pore size (nm <sup>2</sup> )	5.48244	5.19043
BJH Adsorption mean hole width(nm <sup>2</sup> )	14.7987	8.5994
BJH Desorption Mean Pore width(nm <sup>2</sup> )	5.9646	6.4407
Single point adsorption total pore volume of pores less than 40.4123 nm <sup>2</sup> width at P/Po = 0.950000000 (cm <sup>3</sup> g <sup>-1</sup> )	0.088203	0.045663
correlation coefficient	0.9999159	0.9998018

**Table S2**

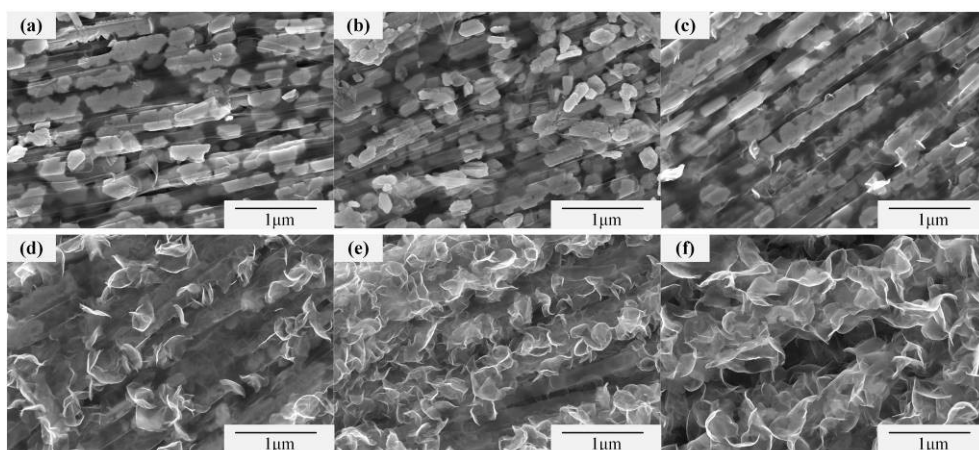
	<b>Rf(Ω)</b>	<b>Rct(Ω)</b>
<b>MoS<sub>2</sub>@C</b>	449.5	72.3
<b>MoS<sub>2</sub>@C-L8</b>	1368	696
<b>MoS<sub>2</sub>@C-L12</b>	867.4	263.8
<b>MoS<sub>2</sub>@C-L</b>	937.5	342.4
<b>MoS<sub>2</sub>@C-H8</b>	538	137.1
<b>MoS<sub>2</sub>@C-H12</b>	1056	128.2
<b>MoS<sub>2</sub>@C-H</b>	1449	180



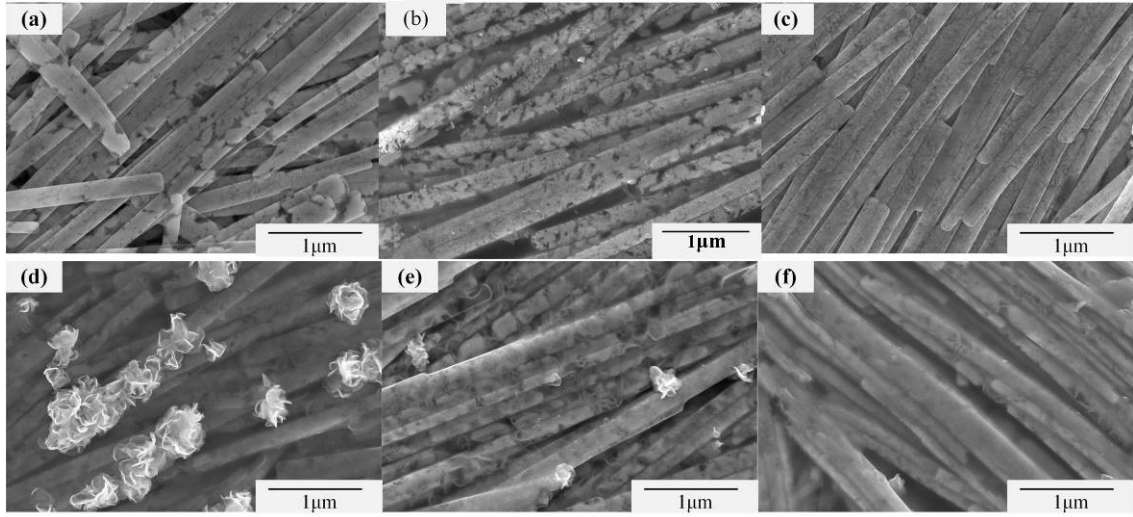
**Fig.S1**



**Fig.S2**



**Fig.S3**



**Fig.S4**



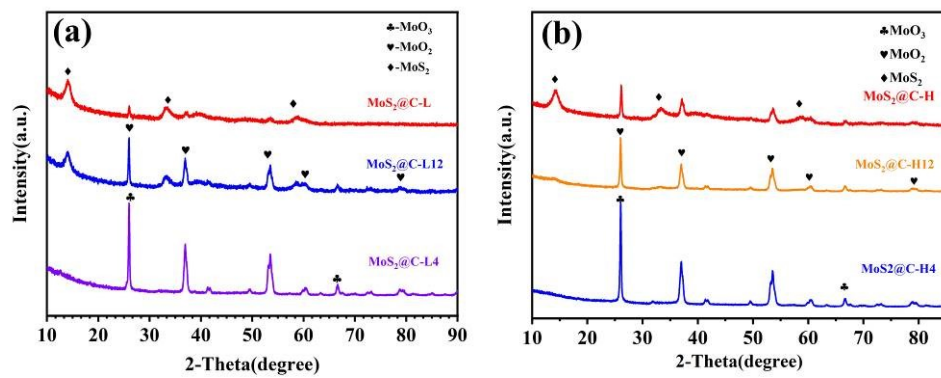


Fig.S5

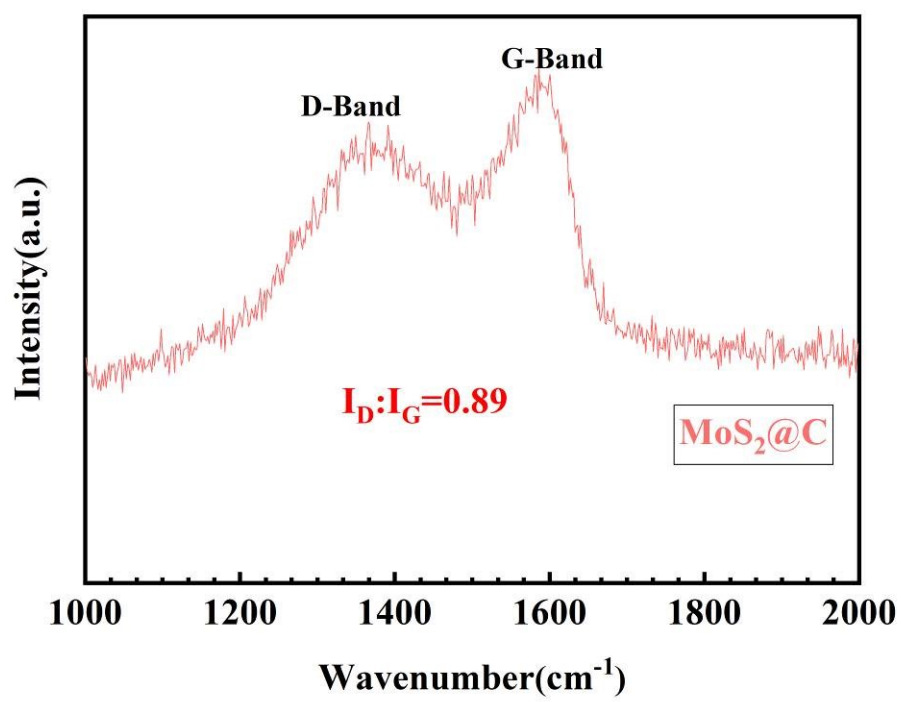


Fig.S6

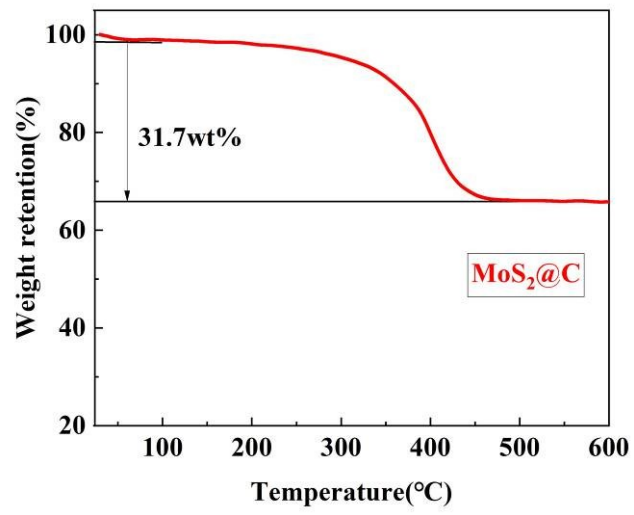


Fig.S7

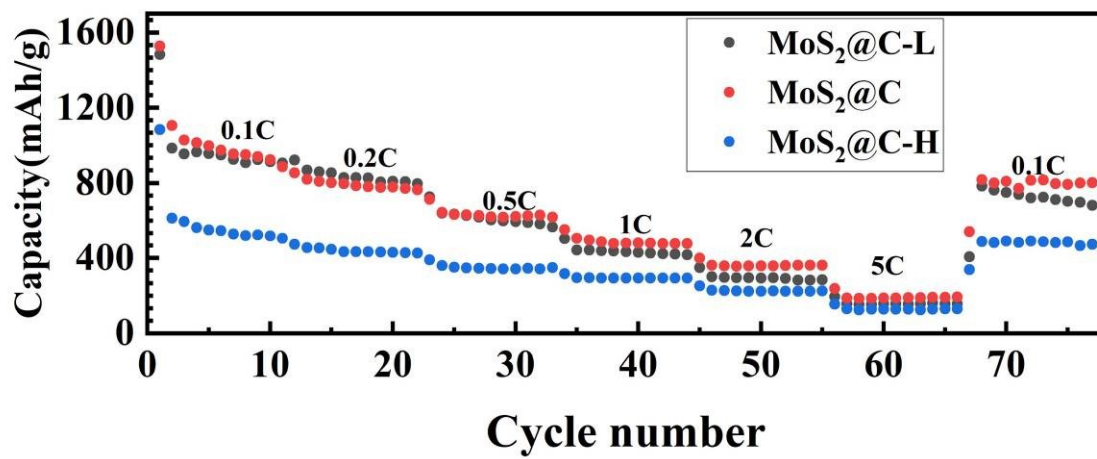


Fig.S8

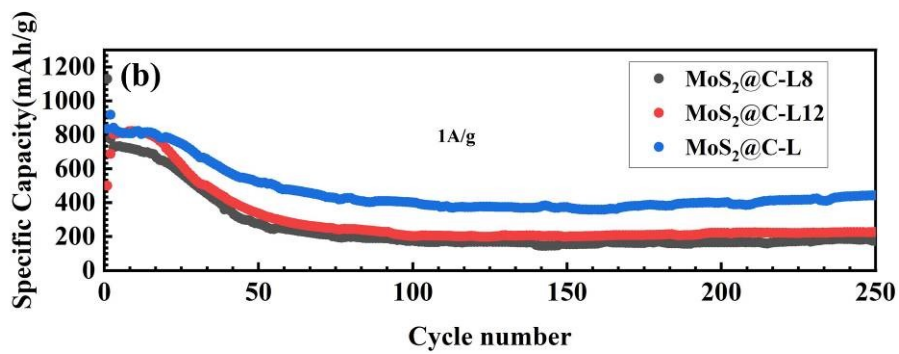
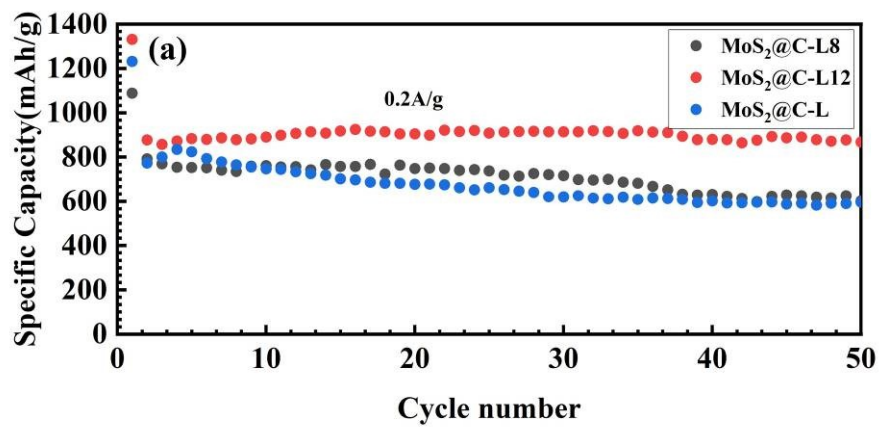


Fig.S9

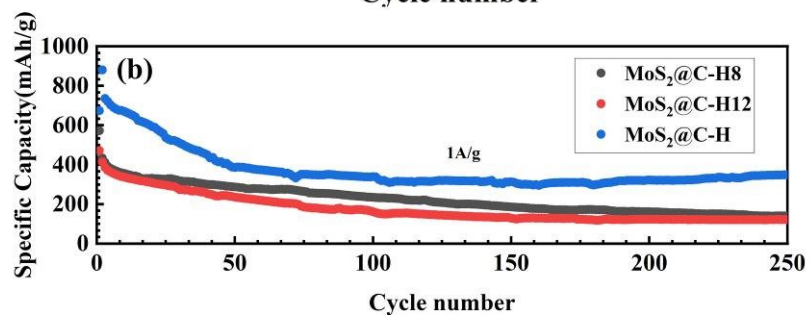
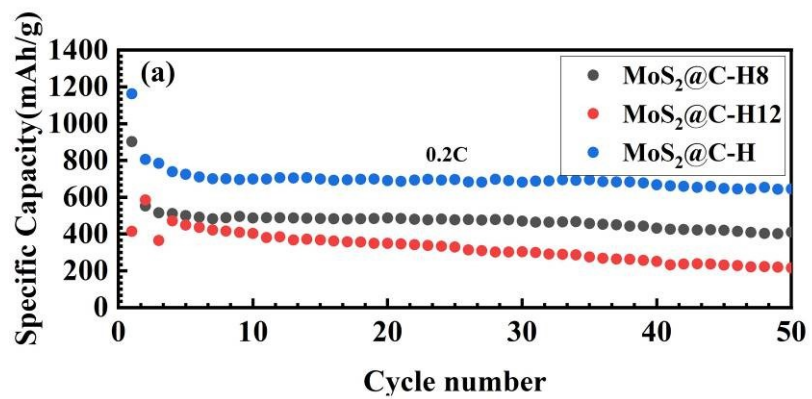


Fig.S10

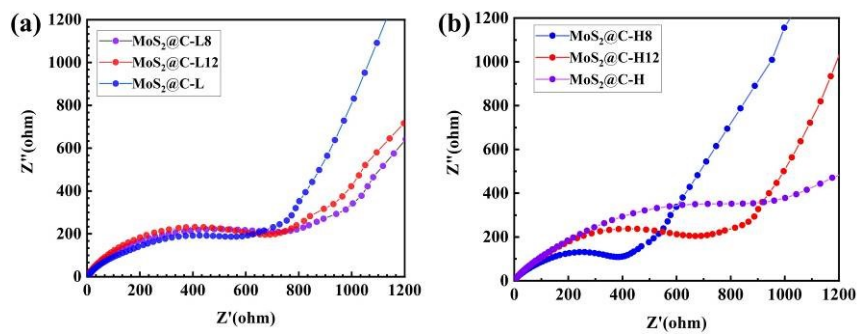


Fig.S11